



μIMU-M Micro Inertial Measurement Unit

Minimizing a highly successful system with no compromises



Northrop Grumman LITEF (NG LITEF) is a worldleading company with over 45 years of experience in Inertial Systems Technology. With its new generation MEMS (Micro Electro Mechanical Systems) technology sensors, NG LITEF continues to design high accuracy Inertial Measurement Units (IMUs) to meet current and future requirements.

MEMS sensor design at NG LITEF started in the early nineties with the B-290, a full silicon accelerometer. This accelerometer has been qualified in systems for attitude heading reference, stabilization and guidance. In 2001 NG LITEF launched the development of the μ CORS (Micro Coriolis Rate Sensor) applying the DRIE MEMS technology.

NG LITEF's extensive experience with its IMUs, based on Fiber Optic Gyros and the MEMS Accelerometer Triad B-290, was the basis of the MEMS

IMU design, resulting in the following advantages for the user:

- Integrated, sealed and self contained unit (3 MEMS rate sensors, 3 MEMS linear accelerometers, electronics, power supply and housing)
- Standard digital interfaces
- Output of fully compensated data (e.g. temperature and misalignment)
- Extensive Built-in-Test features
- Small size, low weight, low power consumption
- Low Life Cycle cost

Typical Applications:

- Applications where high input ranges are required, e.g. missiles, rockets
- Attitude Heading Reference Systems
- Flight control and guidance systems
- Stabilization of platforms

μIMU-M

Micro Inertial Measurement Unit

TECHNICAL DATA

	μIMU-M-SP	μIMU-M-HP
Rate Sensor Parameters		
• Measurement Range	± 1500 °/s	
• Bias In Run Stability (1σ) (*)	≤ 9 °/h	≤ 4.5 °/h
• Bias Repeatability (residual, RMS)	≤ 15 °/h	≤ 6 °/h
• Angular Random Walk	≤ 0.45 °/√h	≤ 0.23 °/√h
• Scale Factor Error (RMS)	≤ 1400 ppm	≤ 1000 ppm
• Axis Misalignment (RMS)	≤ 0.5 mrad	
Linear Acceleration Parameters		
• Measurement Range	± 70 g	
• Bias Repeatability (residual, RMS)	≤ 3 mg	≤ 1.5 mg
• Velocity Random Walk	≤ 0.25 mg/√Hz	≤ 0.07 mg/√Hz
• Scale Factor Error (RMS)	≤ 1500 ppm	≤ 1000 ppm
• Axis Misalignment (RMS)	≤ 0.5 mrad	
System Parameters		
• Mass	0.68 kg, 1.5 lb	
• Dimensions	Ø 85 mm x H 60 mm, Ø 3.35 inch x H 2.36 inch	
• Volume	340 cm ³ , 20.7 inch ³	
• Supply Voltage	+5 VDC	
• Power Consumption	< 8 W	
• Interface	RS 422, HDLC	
• Data Rate	50 to 1024 Hz	
• Built in Test (BIT)	Power up BIT, Continuous BIT	
• Acoustic noise level	140 dB	
• Random vibration level [10...2000 Hz]		
- operational	11.7 g _{RMS}	
- survival	11.7 g _{RMS}	
• Shock		
- operational	40 g / 11 ms / 3 axes	
• Temperature		
- operating	- 55 °C to + 71 °C (short term + 85 °C)	
- storage	- 55 °C to + 71 °C	

(*) Implying Allan Variance under constant temperature conditions and cluster time 24 h.

For more information,
please contact:
Northrop Grumman LITEF GmbH
Loerracher Str. 18
79115 Freiburg, Germany
Phone: +49 761 4901-0
Fax: +49 761 4901-480
marketing@ng-litef.de
www.northropgrumman.litef.com

ppm GmbH
Grube 39a
82377 Penzberg
Germany

Tel: +49 (0) 88 56 8 03 09 80
Fax: +49 (0) 88 56 8 03 09 88

info@ppmgmbh.com
www.ppmgmbh.com



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